

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application No.	:	10/566,116	Confirmation No. 3700
Applicant	:	Akihisa Inoue et al.	
371 Filed	:	January 24, 2006	
Art Unit	:	1742	
Examiner	:	Weiping Zhu	
Customer No.	:	00270	
Title	:	SPUTTERING TARGET AND METHOD FOR PRODUCTION THEREOF	

Mail Stop RCE  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

**AMENDMENT**

Sir:

This is an Amendment submitted with a Request for Continued Examination (RCE). It is in response to the FINAL Office Action dated April 30, 2007. Kindly amend the application as set forth below.

**Amendments to the Claims** are reflected in the listing of claims which begins on page 2 of this paper.

**Remarks** begin on page 6 of this paper.